

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ichio YUDASAKA et al.

Application No.: 09/936,040

Filed: September 7, 2001

Docket No.: 110554

For: SYSTEM AND METHODS FOR MANUFACTURING A THIN FILM TRANSISTOR  
(AS AMENDED)

SUPPLEMENTAL PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office  
Washington, D. C. 20231

Sir:

Further to the Preliminary Amendment filed on September 7, 2001, and prior to initial examination, please amend the above-identified application as follows:

IN THE DRAWINGS:

Please amend Figures 2(D), 3(E), 5(E), 6(D), 10(D), 14(D), 16(E) and 18 as set forth in red in the attached Request for Approval of Drawing Corrections.

IN THE TITLE:

Please replace the title as follows:

SYSTEM AND METHODS FOR MANUFACTURING A THIN FILM TRANSISTOR

IN THE ABSTRACT:

Please replace the Abstract filed with the attached Abstract hereto.

IN THE SPECIFICATION:

Please replace the specification with the substitute specification attached hereto.

09/936040